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Application No.	Applicant(s)
10/633.154	ROH, JAE-WOO
Examiner	Art Unit
Uyen-Chau N. Le	2876
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on's Patent Drawing Revie Amendment / Comment of 84(c)) should be written on	or in the Office action of the drawings in the front (not the back) of
	ERIAL must be submitted. Note the OLOGICAL MATERIAL.
6. ☐ Interview S Paper No 8), 7. ☐ Examiner's 8. ☑ Examiner's	Informal Patent Application (PTO-152) Summary (PTO-413), ./Mail Date s Amendment/Comment s Statement of Reasons for Allowance
	Examiner Uyen-Chau N. Le vars on the cover sheet w (OR REMAINS) CLOSED or other appropriate commod GHTS. This application is and MPEP 1308. aminer. der 35 U.S.C. § 119(a)-(d) been received. been received in Application to fill enterprise to the attached EX as reason(s) why the oath of the submitted. on's Patent Drawing Reviews Amendment / Comment of the header according to 37 C sit of BIOLOGICAL MATFOR THE DEPOSIT OF B

Application/Control Number: 10/633,154

Art Unit: 2876

DETAILED ACTION

Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Allowable Subject Matter

- 2. Claims 1-9 are allowed.
- 3. The following is an examiner's statement of reasons for allowance:

The prior art of records to and all other cited references, taken alone or in combination, fails to teach or fairly suggest the specific structure or the method of a holographic ROM system comprising, among other things, mask for modulating a certain portion of the expanded laser beam to thereby generate a signal beam which is directly provided a holographic medium and sifting the remainder portion of the expanded laser beam to thereby generate reference beam which is provided conical mirror reflecting the reference beam toward the holographic medium, wherein holographic medium includes: a recording region onto which both the reference beam and the signal beam are projected; and a transparent region which passes through the reference beam sifted by the mask, to thereby provide the reference beam to the conical mirror as set forth in the claims combination.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/633,154

Art Unit: 2876

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's

disclosure.

The patents to Jachimowicz et al (US 5,789,733); Custis (US 6695213); Hesselink et al (US

6104511); Campbell et al (US 5835470); Kirk (US 4566031); Hart et al (US 5675437); Yagi et al

(US 6556531) are cited as of interest and illustrate a similar structure to an apparatus and system of

a holographic ROM system.

5. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to Uyen-Chau N. Le whose telephone number is 571-272-2397. The examiner

can normally be reached on MON, TUES AND THURS-SAT 5:30-2:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor,

MICHAEL G LEE can be reached on 571-272-2398. The fax phone number for the organization

where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR system,

see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system,

contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Uyen-Chau N. Le

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April 5, 2004

MICHAEL G. LEE SUPERVISORY PATENT EXAMINER

Page 3

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